

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

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| Jaiswal | Docket No.: TI-34403.1 |
| Serial No.: TBD | Examiner: TBD |
| Filed: 10/6/2003 | Art Unit: TBD |
| For: CONTROL OF NICHROME RESISTOR TEMPERATURE COEFFICIENT USING RF PLASMA SPUTTER ETCH | |

PRELIMINARY AMENDMENT

Honorable Assistant Commissioner
of Patents
Washington, D.C. 20231

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Date of Deposit: October 6, 2003.

Prior to the examination of the above identified application, please amend the above referenced Application as follows: